

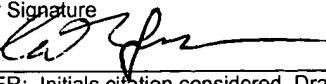
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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 12732-086001	Application No. 10/022,262
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Shunpei Yamazaki et al.	O P E JAN 06 2003 P A T E N T & T R A D E M A R K O F F I C E
		Filing Date December 20, 2001	

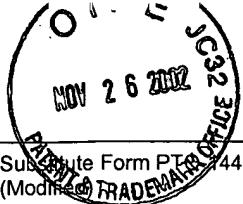
U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
AK	AA	6,359,320	03/19/2002	Yamazaki et al.			08/31/1999
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation Yes No
AK	AL	EP 0 989 614 A2	03/29/2000	Europe	H01L	29/786	
	AM						
	AN						
	AO						
	AP						

Other Documents (include Author, Title, Date, and Place of Publication)							
Examiner Initial	Desig. ID	Document					
AK	AQ	Stanley Wolf, "Contact-Hole and Via Filling with Selective Electroless Metal Deposition"; <i>SILICON PROCESSING FOR THE VLSI ERA - Volume II</i> ; pp. 256-257; 1990					
	AR						
	AS						
	AT						

Examiner Signature 	Date Considered 3-21-03
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		Filing Date December 20, 2001	Group Art Unit 2813	

U.S. Patent Documents

Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
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	AF						
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	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
AA	AL	2001-313397	11/09/2001	Japan			ABS	
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

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